

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S1	806	wafer near3 cleaning.clm.	USPAT; EPO; JPO	OR	ON	2005/02/22 17:39
S2	22	S1 and pivot\$5.clm.	USPAT; EPO; JPO	OR	ON	2005/02/22 17:37
S3	218	wafer near5 roll\$5.clm.	USPAT; EPO; JPO	OR	ON	2005/02/22 17:39
S4	4	S3 and ((clamp\$5 force pressure) near3 (test\$5 detect\$5 sens\$5 estimat\$5 evaluat\$5 determin\$5 measur\$5 transducer cell meter gauge monitor\$5)).clm.	USPAT; EPO; JPO	OR	ON	2005/02/22 17:45